

European Network on New Sensing Technologies for Air Pollution
Control and Environmental Sustainability - *EuNetAir*

COST Action TD1105

Final Meeting at PRAGUE (CZ), 5-7 October 2016

New Sensing Technologies for Air Quality Monitoring

Action Start date: 01/07/2012 - Action End date: 15/11/2016 - EXTENSION:
15/11/2016

Gas sensors based on CuO-TiO₂ heterostructures

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Function in the Action (MC, WG1&2, SIG II member)

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 **cost**
EUROPEAN COOPERATION IN SCIENCE AND TECHNOLOGY



Scientific context and objectives in the Action

o **Contribute to WG1 objectives:**

Fabrication of TiO₂ and ZnO nanostructures such as nanowires, nanotubes and nanorods for all transducers to be implemented

Doping of TiO₂ and ZnO nanostructures

Characterization of metal oxide nanostructures

o **Contribute to WG2 objectives:**

Design of sensor devices for Air Quality

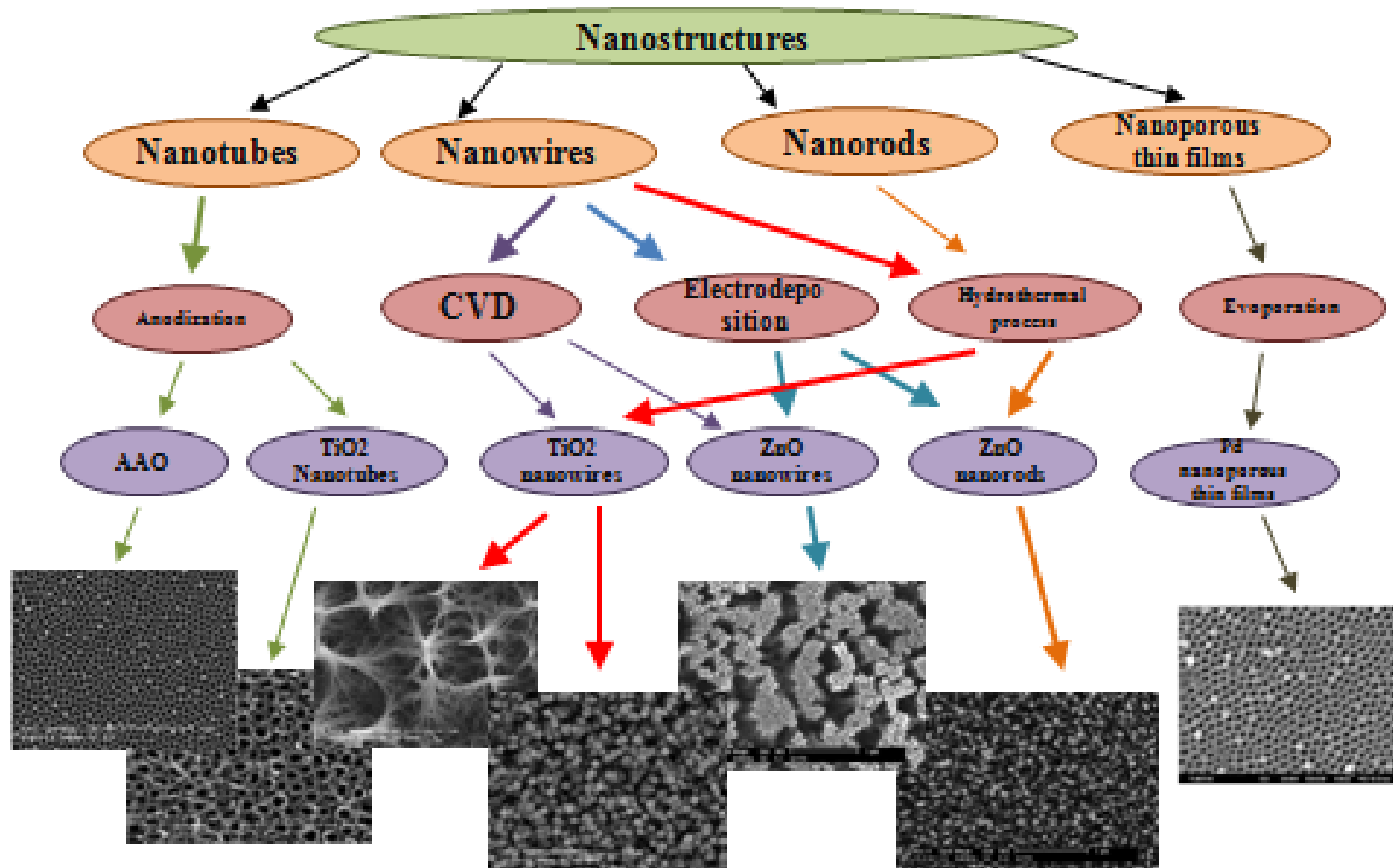
Fabrication of sensor devices based TiO₂ and ZnO nanostructures for air pollutants such as CO, NO₂ and H₂

Characterization of metal oxide nanostructures

Characterization of sensor devices

Fabrication of sensor arrays

Current research activities of GTU



Research Facilities available for GTU

FABRICATION

Anodization

Coating

Hydrothermal

AAO Templates

Sputtering

TiO₂ Nanorods

TiO₂ Nanotubes

Thermal Evaporation

TiO₂ Nanowires

Spin Coating

ZnO Nanorods

Sprey Coating

Dip Coating

CHARACTERIZATION

Structural

Electrical

AFM

I-V

XRD

C-V

SEM

EDS

GAS TEST

H₂

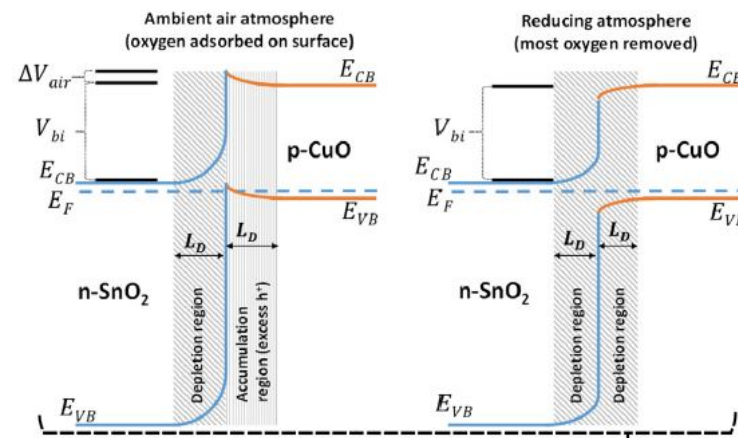
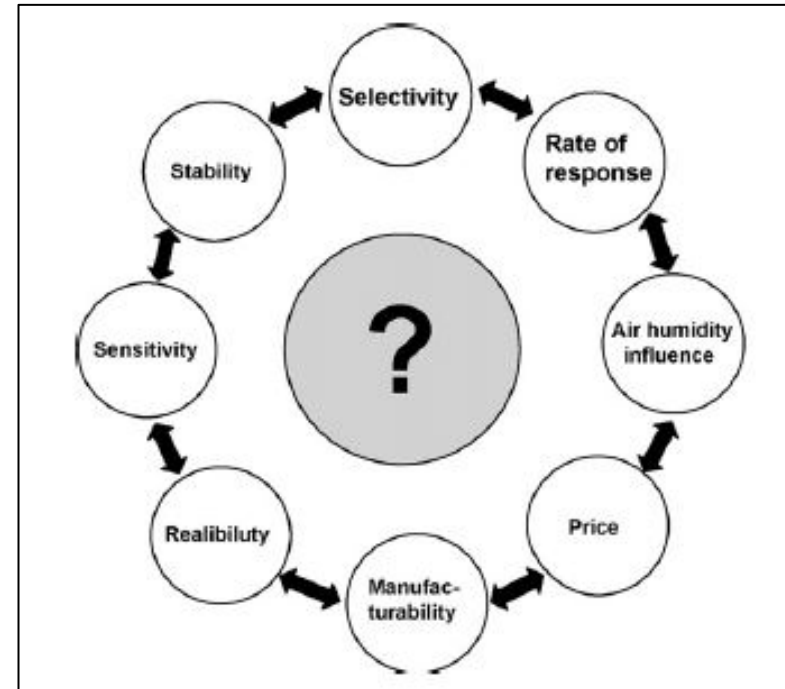
VOCs

CO

NO₂

Suggested R&I Needs for future research

- I. Metal-oxide gas sensor
- II. Nanostructured MOS
- III. Surface modification
- IV. Heterostructures



Experimental

FABRICATION

- I. Anodization
- II. Thermal evaporation
- III. Thermal oxidation

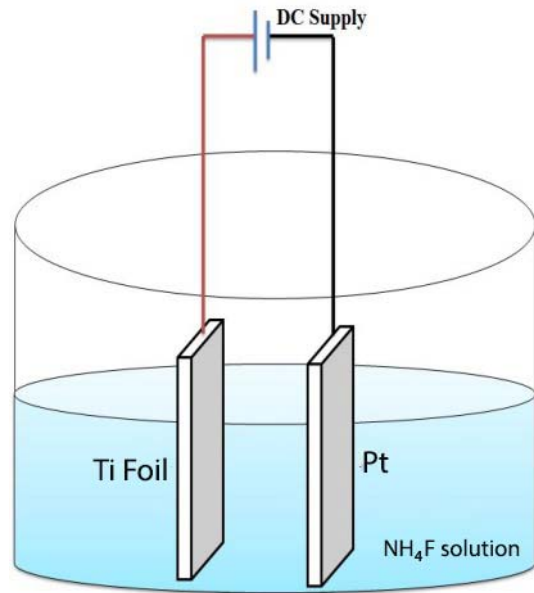
CHARACTERIZATION

- I. XRD
- II. SEM
- III. EDS

SENSOR MEASUREMENTS

- I. H₂
- II. VOCs
- III. NO₂

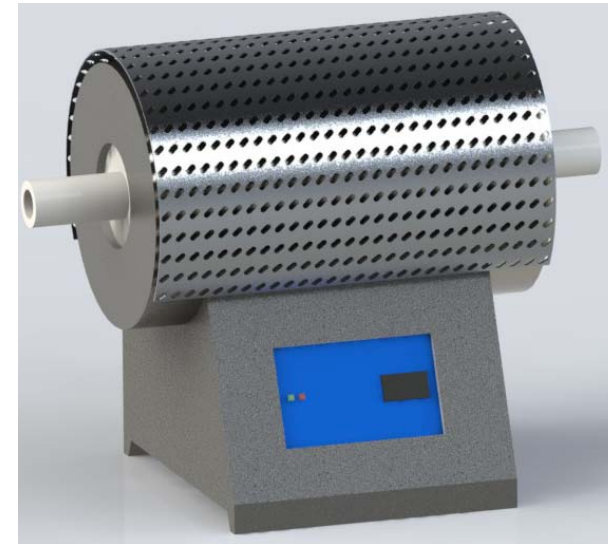
Fabrication of TiO₂ NTs



Anodization

Solution: % 0,25wt NH₄F in ethylene glycol

Process: 0° C, 50V, 60 min.

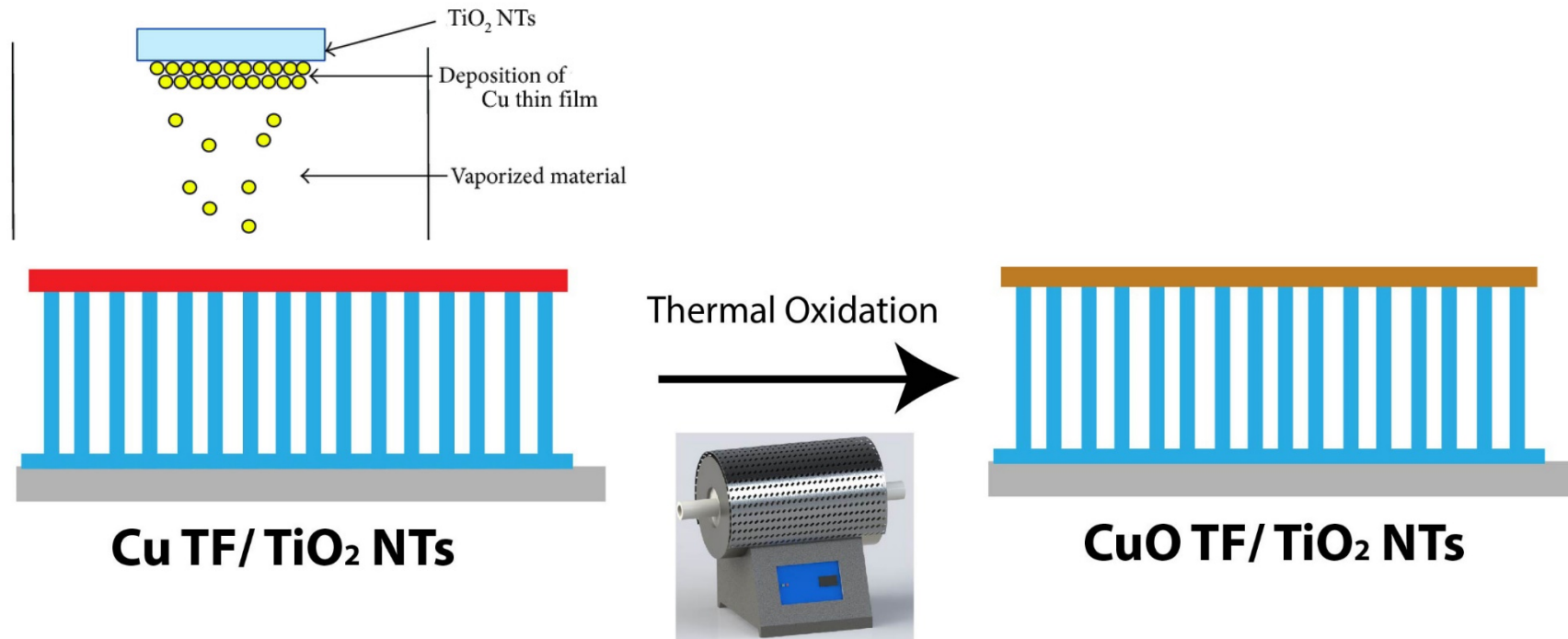


Annealing

In dry air
at 300° C

for 3 h.

Fabrication of CuO/TiO₂ NTs



Cu TF/ TiO₂ NTs

CuO TF/ TiO₂ NTs

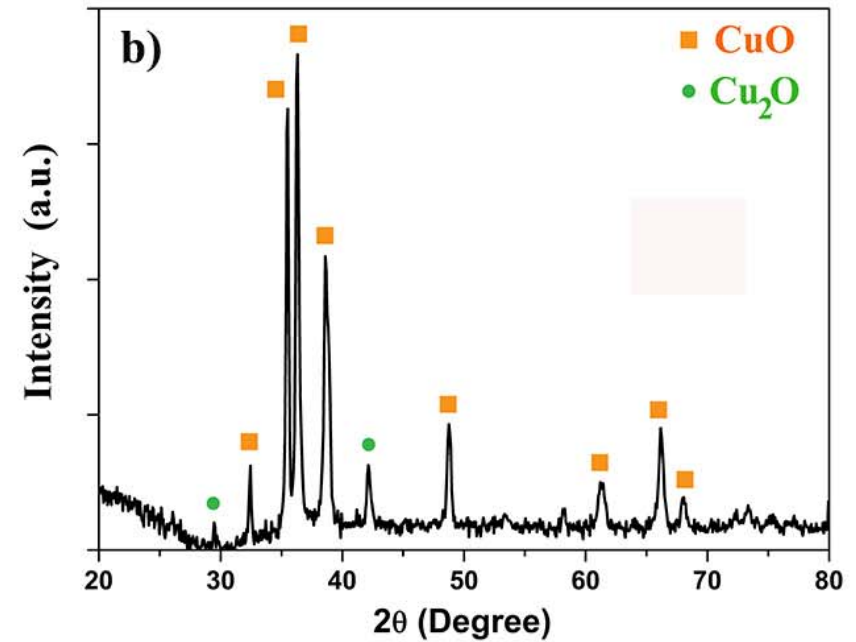
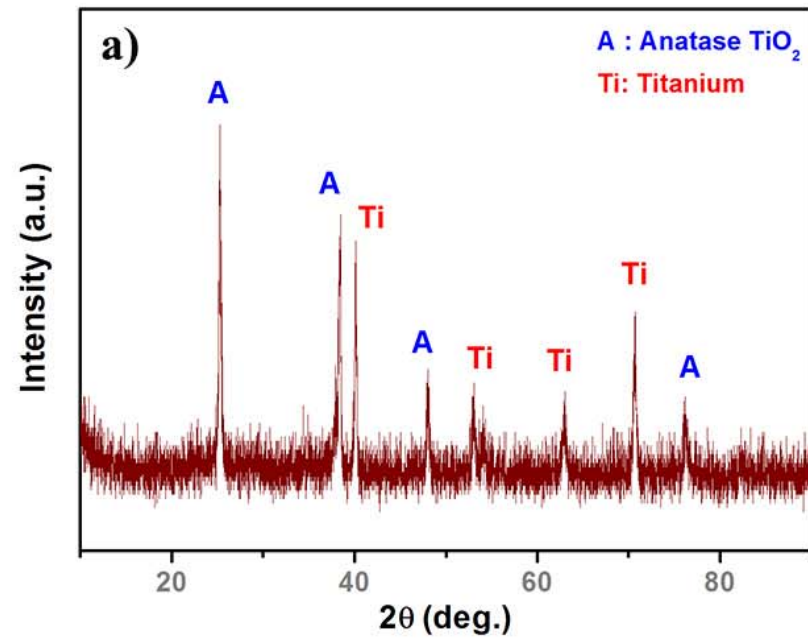
Thermal Evaporation;

- Leybold evaporation system
- 5×10^{-6} bar
- 100 nm Cu

Thermal Oxidation;

- In dry air
- 3 hour
- 400° C

Characterisation; XRD

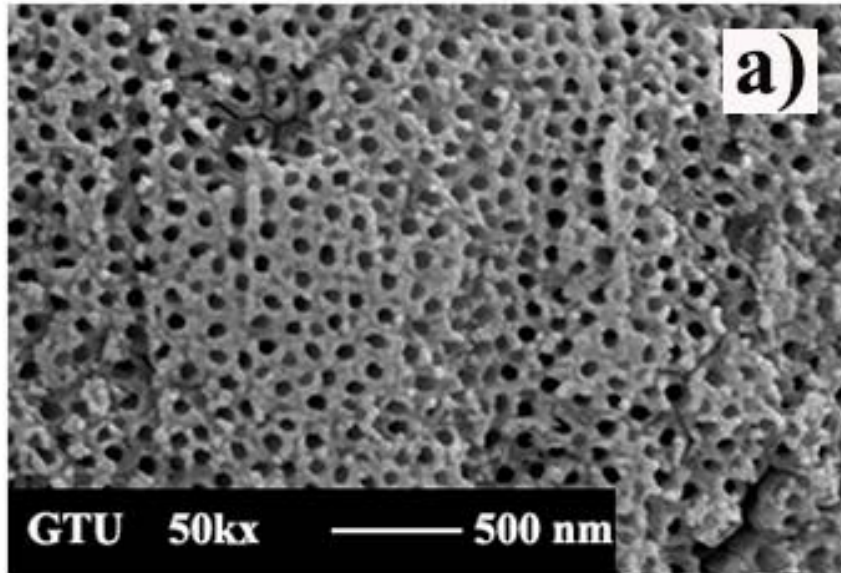


XRD pattern, GTU Rigaku Smartlab X-ray Diffraction

Sennik et al., *J. All. Comp.* 2014, 616, 89-96, Zhao et al., *J. Mater. Chem. A*, 2013,1, 367-:

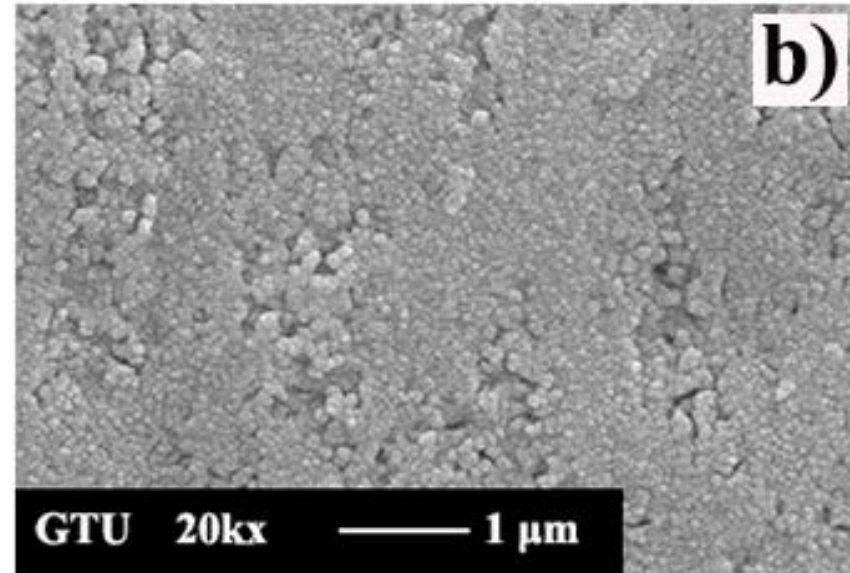
Characterisation; SEM

TiO₂ NTs



- ✓ 50 nm in diameter
- ✓ 1 μm in length
- ✓ Homogenously covered

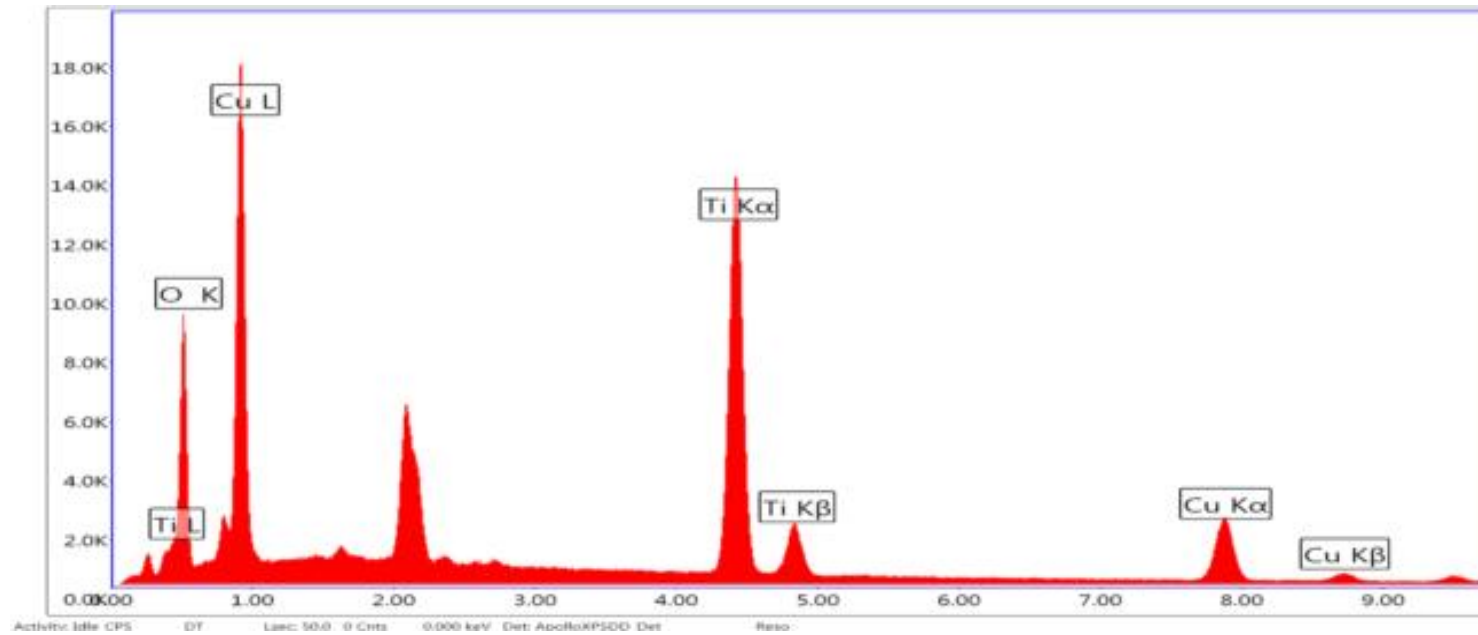
CuO TF/TiO₂ NTs



- ✓ Homogenously covered
- ✓ 100 nm thickness

SEM images, Gebze Technical University Philips XL 30 S

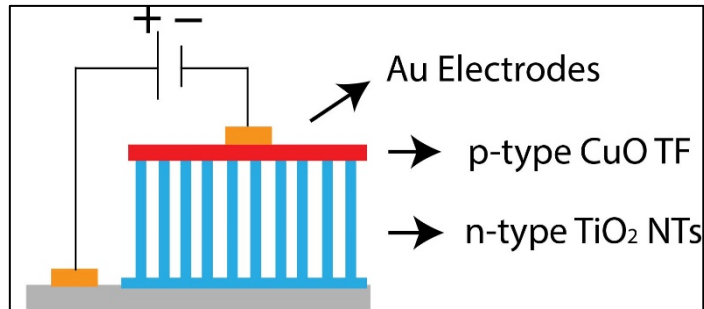
Characterisation; EDS



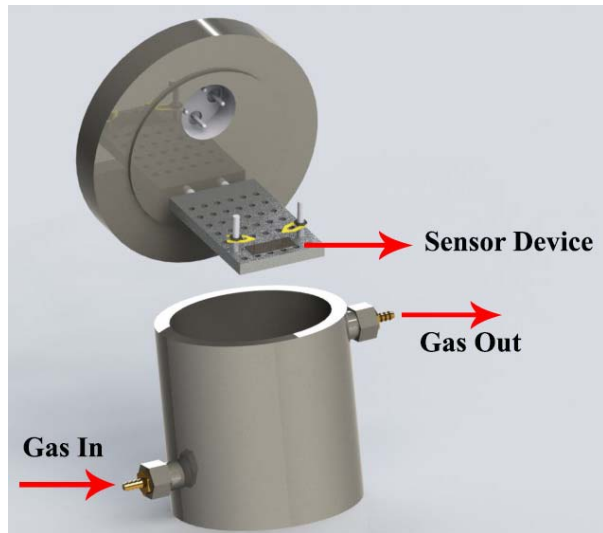
Element	Weight %	Atomic %
O K	27.44	54.41
Ti K	46.39	46.39
Cu K	26.16	26.16

EDAX Team EDS, Gebze Technical U.

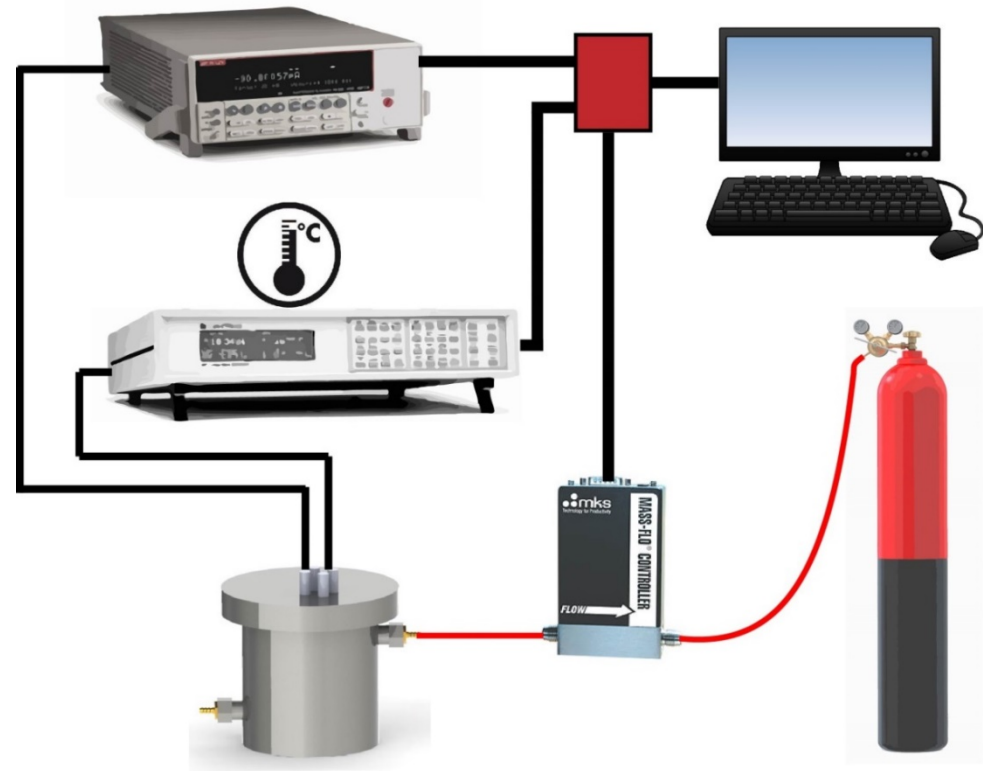
Sensor Measurement



Sensor Device

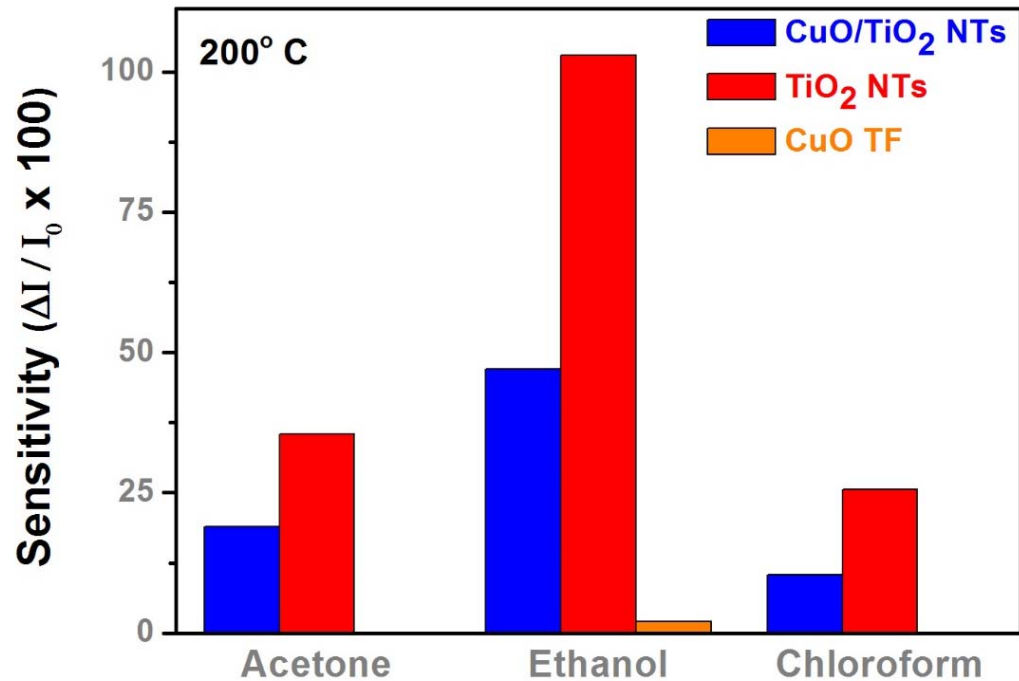


Gas Measurement Chamber



Gas Measurement System

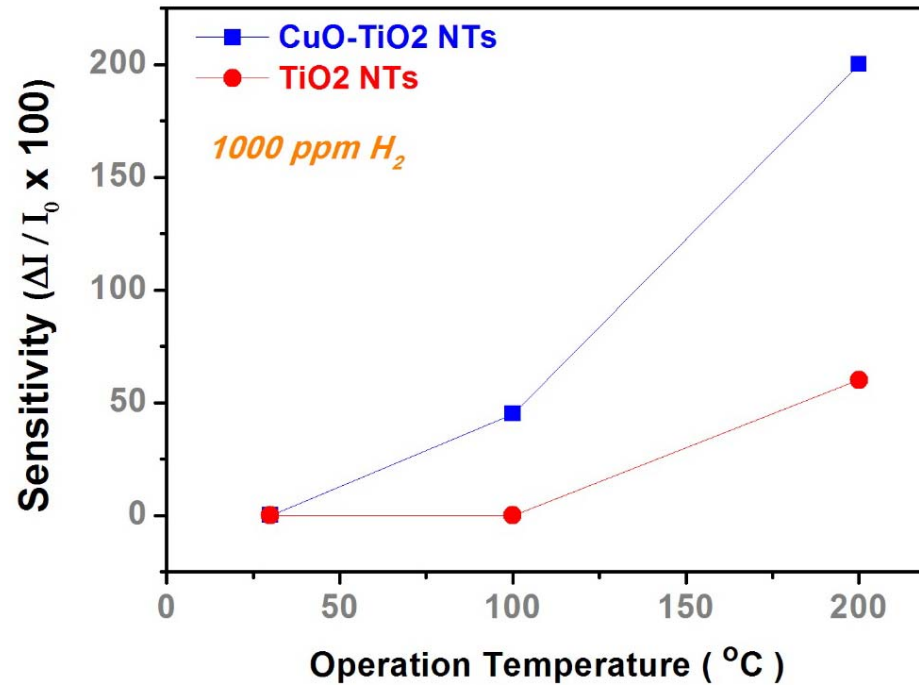
Sensor Measurement



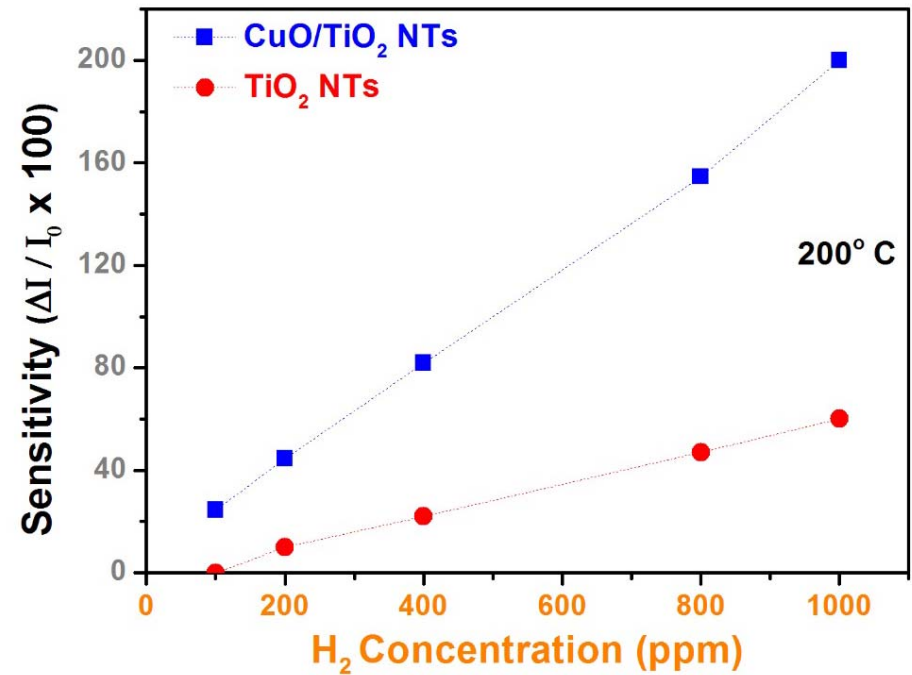
Sensitivity (%) against 5000 ppm VOCs at 200° C.

- The heterostructure, TiO₂ NTs and CuO TF showed no response against VOCs below operation temperature of 200° C.
- CuO TF could only sense ethanol at 200° C.

Sensor Measurement

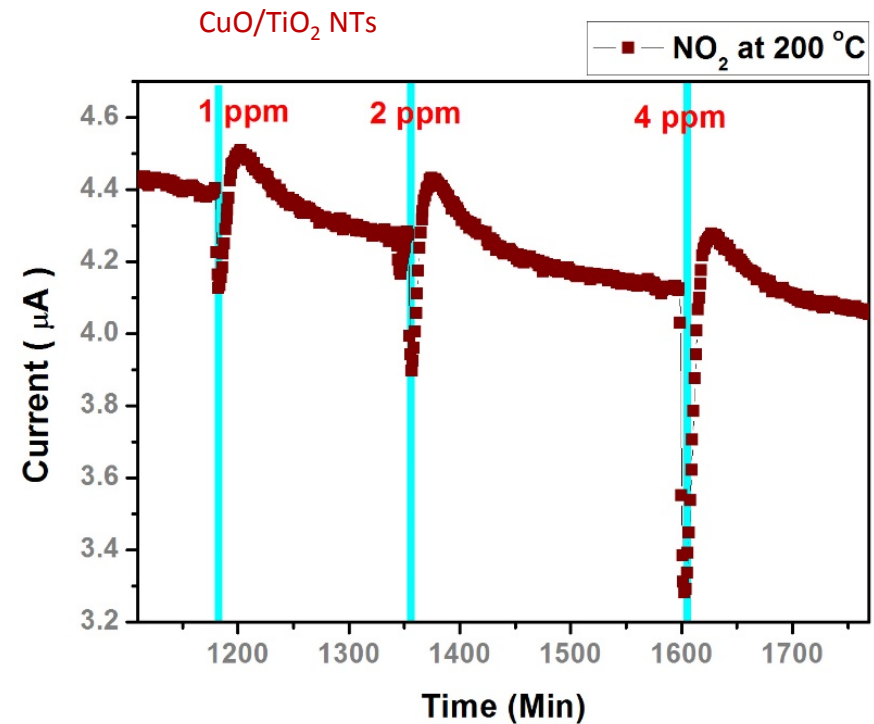
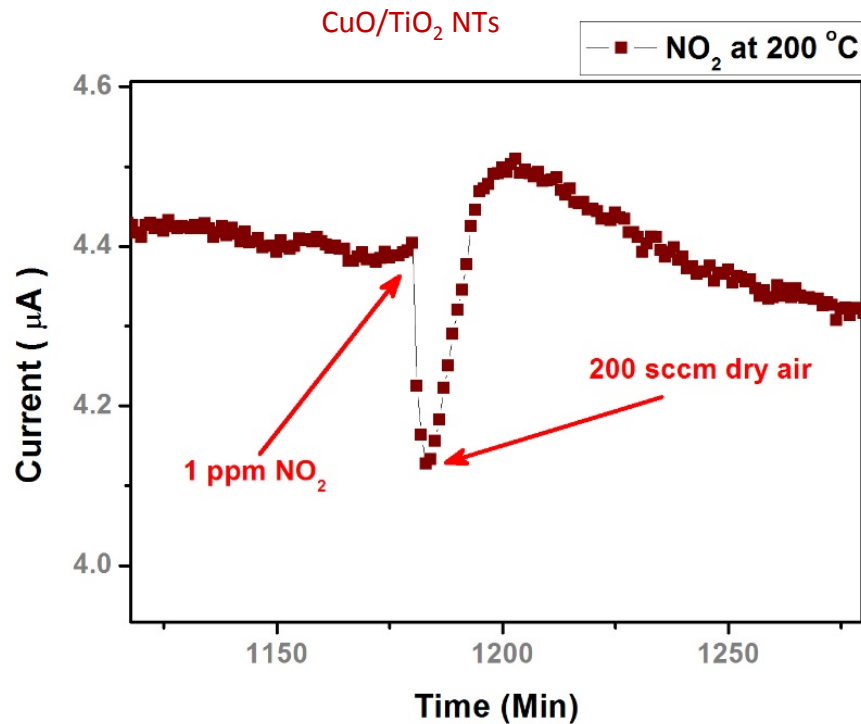


Sensitivity (%) dependent on operation temperature against 1000 ppm H₂



Sensitivity (%) dependent on H₂ concentration at operation temperature of 200° C

Sensor Measurement



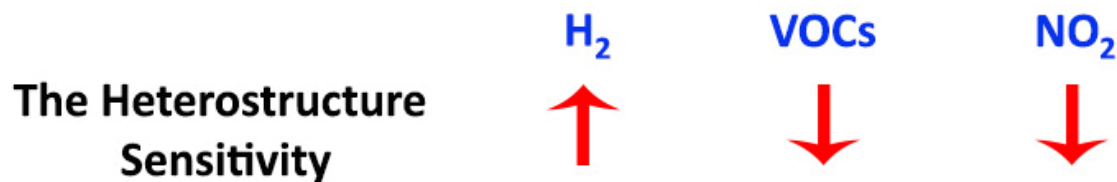
- Though the heterostructure could detect NO₂, sensor response is very low compared to TiO₂ NTs.
- CuO TF showed no response against NO₂.

Conclusions

The heterostructure sensor has better sensitivity, lower detection limit and lower operation temperature against H_2 than the TiO_2 NTs sensor and CuO TF sensor.

Though the heterostructure sensor has clear response against NO_2 and VOCs (ethanol, acetone and chloroform) at operation temperature of $200^\circ C$, sensor responses are very low compared to TiO_2 sensor.

Selectivity the heterostructure formation not only increases the H_2 sensitivity but also decreases the VOCs and NO_2 sensitivity.



This means the heterostructure sensor is selective against H_2 among tested gas species.

ACKNOWLEDGEMENTS

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COST

THANK YOU FOR ATTENTION!